

Unabridged Table of Contents

1. General Information

Control tables.....	24
Using control tables	25
Some specifics	27
Gas control.....	27
Columns	27
Signals	27
Automation	27
Methods and sequences	27
Valves.....	28
Strategy	28
Maintenance information	29
Fuses and batteries	29
Maintenance schedule	30
General warnings.....	31
Many internal parts of the GC carry dangerous voltages	31
Electrostatic discharge is a threat to GC electronics.....	31
Many parts are dangerously hot.....	32
Shutting down the GC	33
For less than one week	33
For more than one week	33

2. The Keyboard and Display

The display	36
The status board	39
The keyboard	40
Instant action keys [Start], [Stop], and [Prep Run]	41
Function keys.....	41
Short-cut keys [Temp], [Pres], [Flow], [Det Control], [Ramp #]	43
[Temp], [Pres], and [Flow]	43
[Det Control].....	44
[Ramp #]	45
[Info].....	46
[Status]	48
The Ready/Not Ready status table	48
The setpoint status table	49
Procedure: Configuring the setpoint status table	49

Miscellaneous keys.....	50
[Time]	50
Procedure: Setting time and date.....	51
Procedure: Using the stopwatch.....	51
Procedure: Setting up [Post Run]	51
[Run Log].....	52
[Options]	53
[Config]......	56
Modifier keys.....	57
[Mode/Type].....	57
[Clear].....	58
[Delete].....	58
[.]	59
[–]	59
Storage and automation.....	60
Default parameters.....	61
Procedure: Loading the default parameters	61

3. Flow and Pressure Control

Hydrogen shutdown	65
Column shutdown	65
Turning gas flows on and off.....	66
EPC-controlled streams	66
NonEPC-controlled streams	66
Electronic Pneumatic Control (EPC)	67
Interpreting flow and pressure readings	67
Configuration	68
Columns and inlets.....	69
Configure the column	70
Procedure: Configuring a capillary column.....	71
Additional notes on column configuration	72
Configure the carrier gas	73
Procedure: Configuring the carrier gas.....	73
Select a column mode.....	74
The flow modes.....	74
The pressure modes.....	74
Procedure: Selecting a column mode.....	74

Enter the initial flow or pressure or average linear velocity	76
Procedure: Setting initial flow or pressure or average linear velocity.....	78
Enter a flow or pressure program (optional).....	79
Procedure: Programming column pressure or flow	79
Enter the rest of the inlet parameters.....	81
Procedure: Setting the rest of the inlet parameters.....	82
Detectors	84
Gas configuration.....	87
Makeup gas	87
Auxiliary channels.....	88
Procedure: Changing an auxiliary channel frit.....	91
Maintaining EPC calibration	92
Flow sensors.....	92
Pressure sensors	92
Zero conditions	92
Procedure: Zeroing flow and pressure sensors.....	93
NonEPC control	94
Inlets.....	94
Septum purge.....	94
Measuring flow rates	95
Measuring flow rates with a bubble meter.....	95
Where to measure flows	96
Adapters for measuring flow rates	96
Procedure: Measuring gas flows with a bubble meter	97
Interpreting flow meter measurements	98
Flow and pressure problems	99
A gas does not reach the setpoint pressure or flow	99
A gas exceeds the setpoint pressure or flow	100
The inlet pressure or flow fluctuates	100
The measured flow is not equal to the displayed flow	101

4. The Column Oven

Oven capabilities	103
Oven safety	104
Configuring the oven.....	105
Procedure: Setting up an isothermal run	106
Making a temperature-programmed run	107
Oven temperature programming setpoints.....	108
Oven ramp rates	109
Procedure: Setting up a single-ramp program	110
Procedure: Setting up a multiple-ramp program	111
Fast chromatography.....	112
Fast-heating oven.....	112
Configuring the oven	112
Using the oven insert for fast chromatography	113
To install the oven insert.....	113
Removing the insert.....	115
Cryogenic operation.....	116
Cryogenic control setpoints	116

5. Columns and Traps

Capillary columns	120
Column hanger.....	120
Procedure: Preparing capillary columns	121
Procedure: Installing capillary columns in the split/splitless inlet	123
Procedure: Installing capillary columns in the cool on-column inlet	125
Procedure: Installing capillary columns in the purged packed inlet	126
Procedure: Installing capillary columns in the PTV inlet and Volatiles Interface	129
Procedure: Installing capillary columns in NPD and FID detectors	129
Procedure: Installing capillary columns in the TCD	133
Procedure: Installing capillary columns in the μ -ECD	134
Procedure: Installing capillary columns in the FPD	137
Ferrules for capillary columns.....	140
Graphite and graphitized-Vespel ferrules	140
Vespel ferrules.....	140
Packed metal columns	141
Overview: installing packed metal columns	141
Fittings	142

Preparing packed metal columns	143
Procedure: Making a spacer from Teflon tubing	144
Procedure: Installing ferrules on a metal column	146
Procedure: Installing an adapter in a detector fitting	147
Procedure: Installing packed metal columns	148
Ferrules for packed metal columns	149
Packed glass columns	150
Overview: Installing glass packed columns	150
Procedure: Installing glass packed columns	152
Ferrules and O-rings for glass packed columns	154
Conditioning columns	155
Procedure: Preliminary column conditioning steps	156
Procedure: Conditioning a capillary column	157
Procedure: Conditioning packed columns	158
Conditioning chemical traps	159
Calibrating your capillary column (optional)	160
Calibration modes	160
Column calibration procedures	161
Procedure: Estimate the actual column length or diameter from an elution time	161
Procedure: Estimate the actual column length or diameter from the measured flow rate	163
Procedure: Estimate the actual column length and diameter	165
6. Signal Handling	
Using the signal control tables	168
Signal type	168
Value	168
Analog output settings—zero, range, and attenuation	172
Analog zero	172
Procedure: Zeroing signal output	172
Range—for analog outputs only	173
Attenuation—for analog outputs only	174
Data rates	174
Procedure: Selecting fast peaks	175
Digital data handling	175
Digital zero	175

Baseline level shifts	175
Cerity\ChemStation	176
Column compensation	178
Procedure: Creating a column compensation profile	180
Procedure: Making a run using column compensation.....	180
Procedure: Plotting a stored column compensation profile	182
Test plot	182

7. Instrument Automation

Executing events during the run	185
Run time programming	185
Using run time events	186
Procedure: Programming run time events.....	187
The run table	188
Procedure: Adding events to the run table	188
Procedure: Editing events in the run table	189
Procedure: Deleting run time events	189
Clock time programming	190
Using clock time events	191
Procedure: Programming clock time events	191
Procedure: Adding events to the clock table.....	194
Procedure: Editing clock time events	194
Procedure: Deleting clock time events	195

8. Analytical Methods

What is a method?	197
What can you do with it?	197
Creating a method	198
Procedure: Storing a method.....	199
Procedure: Loading a previously stored method.....	200
Procedure: Loading the default method.....	201
Method mismatch	202
User-entered configuration changes	202
Hardware configuration changes.....	202
Procedure: Modifying a previously stored method	203
Procedure: Deleting a stored method	204
Method listings.....	204

9. The Automatic Sampler

Injector control table	207
Procedure: Editing injector setpoints	208
Configuring the injector.....	209
Procedure: Configuring an injector with an eight sample vial turret	210
Procedure: Configuring an injector with a three sample vial turret.....	210
Sample tray setpoints.....	211
Procedure: Editing the sample tray setpoints	211
Procedure: Configuring the bar code reader.....	211
Storing injector setpoints	212

10. Valve Control

The valve box	214
Heating the valves.....	214
Valve temperature programming	215
Configuring an Aux thermal zone	215
Valve control	216
The valve drivers	216
The internal valve drivers	216
The external valve drivers	217
Valve configurations.....	218
Procedure: Configuring a valve	219
Valve control	220
Procedure: Controlling valves from the keyboard.....	220
From the run or clock time tables	220
Valve control examples.....	221
Simple valve—column selection	221
Gas sampling valve	221
Multiposition stream selection valve and sampling valve	223

11. Analytical Sequences

What is a sequence?	226
What can you do with it?	226
Defining a sequence	228
Priority sequence	229
Subsequences	229
Post Sequence	229

Procedure: Creating a sequence	230
Procedure: Creating a sampler subsequence	230
Procedure: Creating a valve subsequence	231
Procedure: Setting the Post Sequence events	232
Procedure: Storing a sequence	233
Procedure: Loading a previously stored sequence	234
Procedure: Modifying a previously stored sequence	235
Procedure: Deleting a sequence	236
Sequence control	236
Sequence status.....	237
Procedure: Starting/running a sequence	237
Procedure: Pausing and resuming a sequence	238
Procedure: Stopping a sequence	238
Aborting a sequence	239
Special considerations when using an integrator.....	240

12. Messages

Not Ready messages	245
Temperature zone not ready	248
Pressure and/or flow not ready	249
Detector not ready.....	249
Valve not ready	251
Other not ready messages	252
Shutdown messages	254
Warning messages	260
Fault messages	264

13. Introduction to Inlets

Inlet types	274
Using hydrogen	274
Procedure: Pressure units: Select psi, kPa, bar	277
The inlet and column control tables	278
The column control tables.....	279
The column control table—defined capillary columns.....	279
The column control table—packed or undefined capillary columns.....	281
What is gas saver?.....	283
Procedure: Using gas saver.....	284

Pre Run and Prep Run.....	285
The [Prep Run] key	285
Procedure: Auto Prep Run.....	285
Septum purge	286

14. The Split/Splitless Inlet

Using a Split/Splitless Inlet	289
Standard and high-pressure versions.....	289
Septum tightening.....	289
Liners.....	290
Procedure: Changing the liner.....	290
Split mode pneumatics	292
The control table—split operation.....	293
Procedure: Using the split mode with the column defined	294
Procedure: Using the split mode with the column not defined	295
Splitless mode pneumatics.....	296
The control table—splitless operation	297
Operating parameters	298
Procedure: Using splitless mode with the column defined	299
Procedure: Using splitless mode with the column not defined	300
Pulsed split and splitless modes.....	301
The control table—pulsed split mode.....	302
Procedure: Using the pulsed split mode	303
The control table—pulsed splitless operation.....	304
Procedure: Using the pulsed splitless mode.....	305
Maintaining a split/splitless inlet	306
Changing septa.....	307
Procedure: Changing the septum.....	308
Changing the O-ring.....	310
Procedure: Changing the O-ring.....	311
Replacing the inlet base seal.....	313
Procedure: Replacing the inlet base seal	314
Replacing the split vent trap filter cartridge.....	316
Procedure: Leak testing the gas plumbing	317
Procedure: Leak testing an EPC split/splitless inlet	318
Procedure: Leak testing a nonEPC split/splitless inlet	320
Procedure: Correcting leaks	322
Procedure: Cleaning the inlet	323

15. The Purged Packed Inlet

Using a Purged Packed Inlet	325
Liners and inserts	326
Procedure: Installing liners.....	327
Procedure: Installing glass inserts	329
The control table	331
Packed columns or column not defined	331
Defined capillary columns	331
Procedure: Using packed and undefined capillary columns	332
Procedure: Using defined capillary columns.....	332
Maintaining a Purged Packed Inlet	333
Procedure: Changing septa	334
Procedure: Changing the O-ring	337
Procedure: Leak testing the gas plumbing	339
Procedure: Leak testing an EPC purged packed inlet	339
Procedure: Leak testing a nonEPC purged packed inlet	341
Procedure: Correcting leaks	343
Procedure: Cleaning the inlet	344

16. The Cool On-Column Inlet

Using a Cool On-Column Inlet	347
Hardware	348
Automatic or manual injection with septum nut.....	350
Septum nuts	350
Septa	351
Manual injection with a cooling tower and duckbill septum.....	351
Procedure: Changing the septum nut or cooling tower and septum	352
Procedure: Installing an insert	353
Procedure: Check the needle-to-column size	354
Procedure: Manual injection with septum nut	355
Procedure: Manual injection with cooling tower	355
Retention gaps	357
Inlet temperature	357
CryoBlast (optional)	357
Track oven mode	357
Temperature programming mode	357
Cryogenic considerations	358

Setpoint ranges.....	358
Procedure: Programming the temperature.....	359
Procedure: Operating the cool on-column inlet	360
Maintaining a Cool On-Column Inlet	361
Cool on-column inlet hardware problems.....	363
The inlet cools very slowly	363
The inlet is unable to reach a temperature setpoint.....	363
The syringe needle bends during injections	363
Procedure: Replacing the fused silica syringe needle	363
Procedure: Installing a fused silica needle	365
Changing septa.....	366
Procedure: Changing septa.....	367
Procedure: Cleaning the inlet	369
Procedure: Leak testing the gas plumbing	371
Procedure: Leak testing a cool on-column inlet	372
Procedure: Correcting leaks	373
 17. The Programmable Temperature Vaporization Inlet	
Introducing the Agilent PTV	377
Operating modes.....	377
System requirements.....	377
System components	377
Sampling heads	378
Heating the inlet.....	379
Additional temperature ramps	380
Cooling the inlet.....	381
Configuring the PTV	381
Shutdown behavior	383
Using the Split Modes	384
Flow pattern	384
Temperature considerations	385
Cold split introduction	385
Hot split introduction	385
Control table parameters—split mode operation	386
Procedure: Using split mode with the column defined.....	386
Procedure: Using split mode with the column not defined.....	387
Pulsed modes	389

Control table parameters—pulsed split mode.....	390
Procedure: Using pulsed split mode with the column defined	391
Procedure: Using pulsed split mode with the column not defined	392
Using the Splitless Modes	393
Flow patterns	393
Temperature considerations	396
Cold splitless introduction.....	396
Hot splitless introduction	396
Control table parameters—splitless operation.....	397
Starting values	397
Procedure: Using splitless mode with the column defined	399
Procedure: Using splitless mode with the column not defined	400
Pulsed splitless mode operation.....	401
Control table parameters—pulsed splitless operation	401
Procedure: Using pulsed splitless mode with the column defined.....	402
Procedure: Using pulsed splitless mode with the column not defined.....	403
Using the Solvent Vent Mode	404
Flow patterns	404
Temperature, pressure, and flow considerations.....	406
Sequence of operations.....	407
Timelines	408
When is Start Run?	409
Control table parameters—solvent vent operation.....	409
Procedure: Using solvent vent mode with the column defined.....	411
Procedure: Using solvent vent mode with the column not defined	412
Large volume injection	413
ChemStation requirements	413
Calculated values	415
Possible adjustments	418
Maintaining a PTV	421
Inlet adapters	421
Procedure: Replacing inlet adapters	421
Procedure: Installing columns	422
The septumless head.....	423
Procedure: Removing the septumless head.....	423
Procedure: Cleaning the septumless head.....	424
Procedure: Replacing the Teflon ferrule	426
The septum head	427

Procedure: Removing the septum head	427
Procedure: Changing the septum.....	429
Glass inlet liners	430
Procedure: Replacing liners.....	431
Replacing the split vent trap filter cartridge.....	433
Procedure: Leak testing the gas plumbing	434
Procedure: Leak testing the PTV inlet	435
Correcting leaks	438
Potential leak points	438
Consumables and replaceable parts	439

18. The Volatiles Interface

Using a Volatiles Interface	442
Split mode.....	443
Understanding the pneumatics	444
Using the control table	444
Operating parameters.....	446
Split ratio.....	446
Procedure: Operating in the split mode with the column defined	447
Procedure: Operating in the split mode with the column not defined.....	447
Splitless mode	449
Understanding the pneumatics	449
Using the control table	450
Operating parameters.....	453
Procedure: Operating in the splitless mode	454
Direct mode.....	455
Understanding the pneumatics	455
Preparing your interface for direct sample introduction.....	457
Procedure: Disconnecting the split vent line	457
Procedure: Configuring for a direct injection	460
Using the control table	460
Operating parameters.....	462
Procedure: Operating in direct mode	462
Maintaining a Volatiles Interface	463
Procedure: Installing columns	464
Procedure: Replacing or cleaning the interface	469
Replacing the split vent trap filter cartridge.....	472
Procedure: Leak testing the gas plumbing	473

Procedure: Leak testing the system	474
Procedure: Preparing the interface for a leak test	476
Procedure: Correcting leaks	477
Connecting to an External Gas Sampler	478
Procedure: Connecting the 7694 headspace sampler	479
Procedure: Connecting the 7695 purge and trap concentrator	483

19. NonEPC Inlets

Purged packed inlet.....	489
Split/splitless inlet—split mode	489
Split/splitless inlet—splitless mode	489
Configuration	489
Procedure: Configuring a nonEPC inlet.....	490
Inlet control tables	491
Column control tables.....	492
Procedure: Setting carrier flow for the purged packed inlet	492
Procedure: Setting flows for the split mode inlet	493
Procedure: Setting flows for the splitless mode	494

20. The Pneumatics Control Module

Using a Pneumatics Control Module.....	498
Operating the PCM	499
With an inlet.....	499
With a valve or other device	500
The control tables.....	500
Packed column or column not defined	501
Defined capillary columns	501
Procedure: Using packed and undefined capillary columns	502
Procedure: Using defined capillary columns	503
Maintaining a PCM	503
Procedure: Leak testing the gas plumbing	503

21. Using Detectors

Using hydrogen	506
Procedure: Setting up detector control tables	507
Makeup gas flow	510
Makeup gas	510
Procedure: Defining the makeup gas	511
Procedure: Changing makeup gas flow mode	511
Maximum flow rates	512
[Det Control] shortcut key	513

22. The Flame Ionization Detector

General Information	515
FID pneumatics.....	515
Special considerations	516
Conditions that prevent the detector from operating	516
Detector shutdown	516
Jets.....	517
Automatic reignition—Lit offset.....	518
Procedure: Changing the auto-reignite setpoint	518
Electrometer	519
Data rates	519
Procedure: Using fast peaks	519
Operating the FID	520
Gas pressures.....	521
Operating with EPC	522
Procedure: Using the FID	523
Checkout Conditions and Chromatogram	524
FID checkout conditions	524
Typical FID checkout chromatogram.....	526
Maintaining a Flame Ionization Detector	527
Correcting FID hardware problems	528
Replacing or cleaning the jet.....	528
Procedure: Removing and inspecting the jet.....	529
Procedure: Cleaning the jet	532
Procedure: Installing the jet	533
Cleaning the collector	535
Procedure: Removing the collector	536

Procedure: Cleaning the collector	538
Procedure: Reassembling the detector	539
Procedure: Replacing the FID ignition wire	541
The Nickel Catalyst Tube	544
Gas flows	544
Temperature.....	545
Repacking the catalyst.....	545

23. The Thermal Conductivity Detector

General Information	550
TCD pneumatics	552
Conditions that prevent the detector from operating.....	552
Filament passivation	553
Carrier, reference, and makeup gas	553
Negative polarity.....	554
Analyzing for hydrogen.....	554
Operating the TCD	555
Gas pressures	556
Operating the TCD.....	557
Procedure: Using the TCD	558
Checkout Conditions and Chromatogram	559
TCD checkout conditions.....	559
Typical TCD checkout chromatogram.....	561
Maintaining a Thermal Conductivity Detector	562
Correcting TCD performance problems	562
Procedure: Thermal cleaning	562

24. The Nitrogen-Phosphorus Detector

General Information	565
Software requirements.....	565
NPD pneumatics	566
Conditions that prevent the NPD from operating	566
Gas purity	567
The bead	567
Adjust offset.....	567
Aborting adjust offset.....	569

Turning off the detector	569
Setting adjust offset on the clock table	569
Equilibration time	569
Procedure: Changing equilibration time	570
Turning hydrogen off during a solvent peak	570
Turning hydrogen off between runs	570
Bead voltage	570
Extending the life of the bead	571
Temperature programming	571
Electrometer	572
Data rates	572
Procedure: Setting data rate for NPD.....	572
Jets and collectors.....	573
Operating the NPD	574
Gas pressures.....	575
Operating with EPC	576
Procedure: Using the NPD	577
Checkout Conditions and Chromatogram	578
NPD checkout conditions.....	578
Typical NPD checkout chromatogram	580
Maintaining a Nitrogen-Phosphorus Detector	581
NPD illustrated parts breakdown.....	581
Correcting NPD hardware problems	582
Procedure: Replacing the bead assembly	585
Procedure: Cleaning detector and collector; changing insulators and rings	590
Replacing or cleaning the jet.....	598
Procedure: Removing and inspecting the jet.....	599
Procedure: Cleaning the jet	601
Procedure: Replacing the jet and reassembling the detector.....	602
25. The Micro-Cell Electron Capture Detector	
Regulatory and Safety Information	604
The 63Ni isotope	605
ECD licenses	605
Specific License.....	605
General License	605
μ-ECD warnings	606

Safety precautions when handling µ-ECDs	608
General Information	609
Linearity	609
Detector gas	610
Temperature	610
Electrometer	610
Operating the µ-ECD	611
Procedure: Operating the µ-ECD	612
Checkout Conditions and Chromatogram	614
µ-ECD checkout conditions	614
Typical µ-ECD checkout chromatogram	616
Maintaining the Detector	617
Correcting performance problems	618
Checking for gas leaks	620
Thermal cleaning	622
Performing a wipe test (radioactivity leak test)	624

26. The Flame Photometric Detector

General Information	626
Linearity	626
Quenching effects	627
PMT saturation	628
Optical filters	628
Fused silica liner	628
Conditions that prevent the detector from operating	628
Detector shutdown	629
Compatibility requirements	629
The dual wavelength FPD	629
Using the Detector	631
Detector temperature considerations	631
Heater configuration	631
Lit offset	632
Procedure: Changing the Lit offset setpoint	632
Flame ignition sequence	633
Lighting the flame	634
Electrometer on/off	634
Electrometer data rates	635

Procedure: Using fast peaks	635
Operating the FPD.....	636
Procedure: Using the FPD	638
Checkout Conditions and Chromatogram	639
FPD checkout conditions	639
Typical FPD checkout chromatograms	641
Maintaining the Detector	642
Flame ignition problems.....	642
Changing wavelength filters.....	643
Leak testing	644
Parts identification	645
Cleaning/replacing windows, filters, and seals.....	649
Cleaning/replacing the jet.....	651
Replacing the transfer line fused silica liner.....	653
Replacing the photomultiplier tube	656

27. Basic Operations

Samples	658
Preparing the GC to run samples	658
Running samples - Manual Injection	658
Running samples - GC ALS or Valve Injection.....	659
Methods	660
Creating Methods	660
Setting a Column Flow Rate or Pressure	661
Sequences	662
Creating sequences.....	662
Start/Stop/Pause a sequence	664
Maintenance	665
Changing the Column.....	665
Checking Performance	667

28. Site Preparation

Temperature and humidity ranges	671
Ventilation requirements	671
Venting oven exhaust	672
Venting toxic or noxious gases	672

Benchtop space requirements	672
Electrical requirements	676
Grounding	676
Line voltage.....	676
USA fast heating oven, 240 V	678
Canadian installation	679
Configuring the GC for an MSD	679
Gas requirements.....	679
Gases for packed columns	679
Gases for capillary columns	680
Gas purity	681
The gas plumbing.....	683
Supply tubing for carrier and detector gases	685
Two-stage pressure regulators	686
Pressure regulator-gas supply tubing connections.....	686
Traps	687
Cryogenic cooling requirements.....	688
Choosing a coolant	688
Using carbon dioxide.....	688
Using liquid nitrogen	690
Supplying valve actuator air.....	692

29. Installation

Step 1. Unpacking the GC.....	698
Step 2. Placing the GC system on the benchtop	699
Step 3. Turning the power on.....	700
Step 4. Connecting tubing to the gas supply tank	702
Step 5. Attaching traps to the gas supply tubing	703
Step 6. Attaching a SWAGELOK™ Tee to tubing	704
Step 7. Attaching tubing to the inlet manifold	705
Step 8. Attaching tubing to detector manifolds	706
6890 with Electronic Pressure Control	706
Step 9. Checking for leaks	707
Step 10. Attaching cryogenic liquid supplies	708
Attaching liquid carbon dioxide	708
Attaching liquid nitrogen.....	709
Step 11. Attaching valve actuator air	711
Step 12. Setting source pressures.....	712

Step 13. Connecting cables.....	713
Cable diagrams	717
Analog cable, general use	717
Remote start/stop cable	718
Binary-coded decimal cable	720
External event cable.....	720
Step 14. Configuring the GC.....	722
Procedure: Setting up a LAN configuration.....	722

30. Making SWAGELOK Connections